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August 21, 2003

MAIL STOP PATENT APPLICATION

Commissioner for Patents P.O. Box 1450

Alexandria, VA 22313-1450

Application of Fujio AKAHANE, Nagamitsu TAKASHIMA, Kazushige HAKEDA, Ryoji UESUGI and Akiharu KUREBAYASHI FORGING PUNCH, METHOD OF MANUFACTURING LIQUID EJECTION HEAD USING THE SAME, AND LIQUID EJECTION HEAD MANUFACTURED BY THE METHOD Assignee: SEIKO EPSON CORPORATION

Our Ref. Q77091

Dear Sir-

Attached hereto is the application identified above comprising forty-four (44) sheets of the specification, including the claims and abstract and twelve (12) sheets of drawings. The requisite U.S. Government filing fee, executed Declaration and Power of Attorney and Assignment will be submitted at a later date.

The Government filing fee is calculated as follows:

Trans.			
Total claims Independent claims Base Fee	$\frac{22}{3} - 20$	= 2 x = x	\$18.00 = \$36.00 \$84.00 = \$.00
TOTAL FEE			\$750.00
			\$786.00

Priority is claimed from:

Country Application No

Filing Date Japan 2002-243484 August 23, 2002 Japan 2003-207934 August 19, 2003

The priority documents will be filed at a later date.

Respectfully submitted, SUGHRUE MION, PLLC

Attorneys for Applicant

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